

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

priority Application Serial No. ....09/995,372  
priority Filing Date .....November 26, 2001  
Inventor.....John T. Moore et al.  
Assignee.....Micron Technology, Inc.  
priority Examiner .....N. Drew Richards  
priority Group Art Unit .....2815  
Customer No. .....021567  
Attorney Docket No. .....MI22-2463  
Title: (As Amended) Semiconductor Wafer Assemblies Comprising Photoresist Over  
Silicon Nitride Materials

**PRELIMINARY AMENDMENT**

To: MS Patent Application  
Commissioner for Patents  
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**AMENDMENTS**

**Introductory Comments**

This preliminary amendment accompanies filing of a continuation application.